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APPLICATION NO.	PLICATION NO. FILING DATE		FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/078,766	10/078,766 02/19/2002		Takeshi Miura	51380	4845	
21874	7590	09/17/2003				
EDWARD		ELL, LLP	EXAMINER			
P.O. BOX 9169 BOSTON, MA 02209				LEADER, WILLIAM T		
				ART UNIT	PAPER NUMBER	
				1742		
				DATE MAILED: 09/17/2003		

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)					
	10/078,766	MIURA ET AL.					
Office Action Summary	Examiner	Art Unit					
	William T. Leader	1742					
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply							
A SHORTENED STATUTORY PERIOD FOR REPL THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1. after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a rep. - If NO period for reply is specified above, the maximum statutory period. - Failure to reply within the set or extended period for reply will, by statul. - Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b). Status	.136(a). In no event, however, may a reply be tin ply within the statutory minimum of thirty (30) day I will apply and will expire SIX (6) MONTHS from te, cause the application to become ABANDONE	nely filed s will be considered timely. the mailing date of this communication. D (35 U.S.C. § 133).					
1) Responsive to communication(s) filed on	·	•					
·_ · _ -	his action is non-final.						
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.							
Disposition of Claims 4) Claim(a) 1.4 in/are pending in the application							
4) Claim(s) 1-4 is/are pending in the application							
4a) Of the above claim(s) is/are withdrawn from consideration.							
5) Claim(s) is/are allowed.							
7) Claim(s) is/are objected to.	6) Claim(s) <u>1-4</u> is/are rejected.						
	8) Claim(s) are subject to restriction and/or election requirement.						
Application Papers							
9)☐ The specification is objected to by the Examiner.							
10)☐ The drawing(s) filed on is/are: a)☐ acce	epted or b)⊡ objected to by the Exa	miner.					
Applicant may not request that any objection to the	he drawing(s) be held in abeyance. S	ee 37 CFR 1.85(a).					
11)☐ The proposed drawing correction filed on	_ is: a)□ approved b)□ disappro	oved by the Examiner.					
If approved, corrected drawings are required in reply to this Office action.							
12)☐ The oath or declaration is objected to by the Examiner.							
Priority under 35 U.S.C. §§ 119 and 120							
13) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).							
a) All b) Some * c) None of:							
1. Certified copies of the priority documen	its have been received.						
2. Certified copies of the priority documen	its have been received in Applicati	on No					
 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 							
14) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).							
a) The translation of the foreign language provisional application has been received.							
15) ☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.							
Attachment(s)							
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449) Paper No(s)	5) Notice of Informal I	r (PTO-413) Paper No(s) Patent Application (PTO-152)					

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DETAILED ACTION

Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.
- 2. Claims 1-4 are rejected under 35 U.S.C. 102(e) as being anticipated by Chen (6,197,181).
- 3. The Chen patent is directed to a process for applying a copper metallization interconnect structure to a semiconductor workpiece. As explained by Chen in the discussion of the background of the invention, a plurality of integrated circuit chips are constructed on a single 8 inch diameter silicon wafer. Interconnections within each chip are made by conductor paths formed within a dielectric layer which separates different levels of the conductor paths (column 1, lines 16-30). Fig.2A shows a trench 5 to be filled with copper metallization. A thin barrier layer 10 of, for example, titanium nitride or tantalum nitride is deposited over the surface of the semiconductor device (column 3, line 66 column 4, line 10). After deposition of the barrier layer, copper seed layer 15 is deposited (column 4, lines 11-15).

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enhance the seed layer (column 4, lines 50-56). The electrolytic bath used for enhancing the seed is a solution in which copper ions are complexed with a complexing agent (column 5, lines 34-36). Citric acid may be used as the complexing agent. When citric acid is employed, a preferred pH is about 9.5 (column 5, lines 54-55). This pH value falls within the range recited in instant claim 1. The process of electrodepositing copper from the disclosed solution to enhance the initially formed seed layer is illustrated in example 1. All elements recited in instant claims 1-4 are disclosed by Chen.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to William T. Leader whose telephone number is 703-308-2530. The examiner can normally be reached on Mondays-Thursdays and alternate Fridays, 7:30-4:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Roy King, can be reached on 703-308-1146. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

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Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0661.

ROY KING SUPERVISORY PATENT EXAMINER

TECHNOLOGY CENTER 1700

William Leader September 10, 2003